

FIG. 1

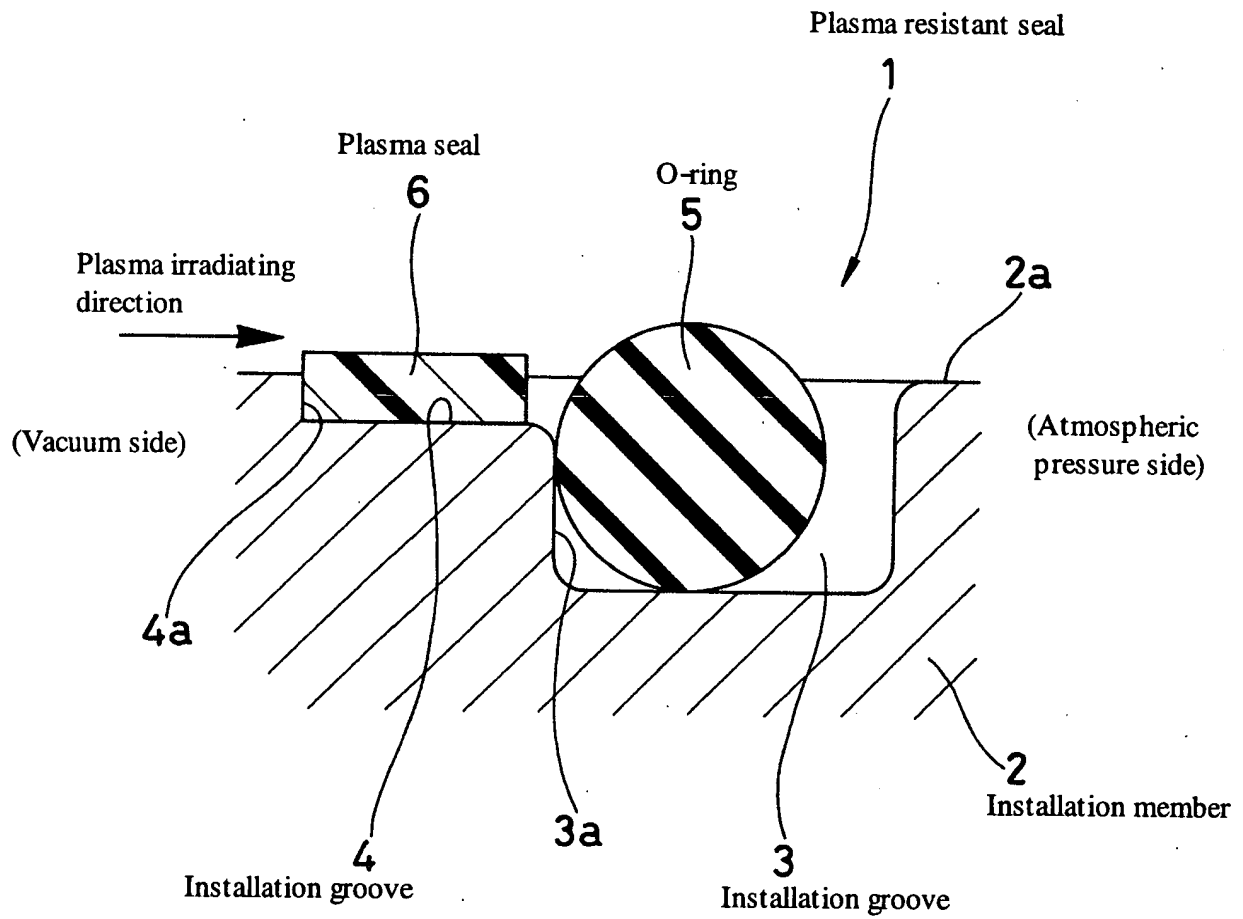


FIG. 2

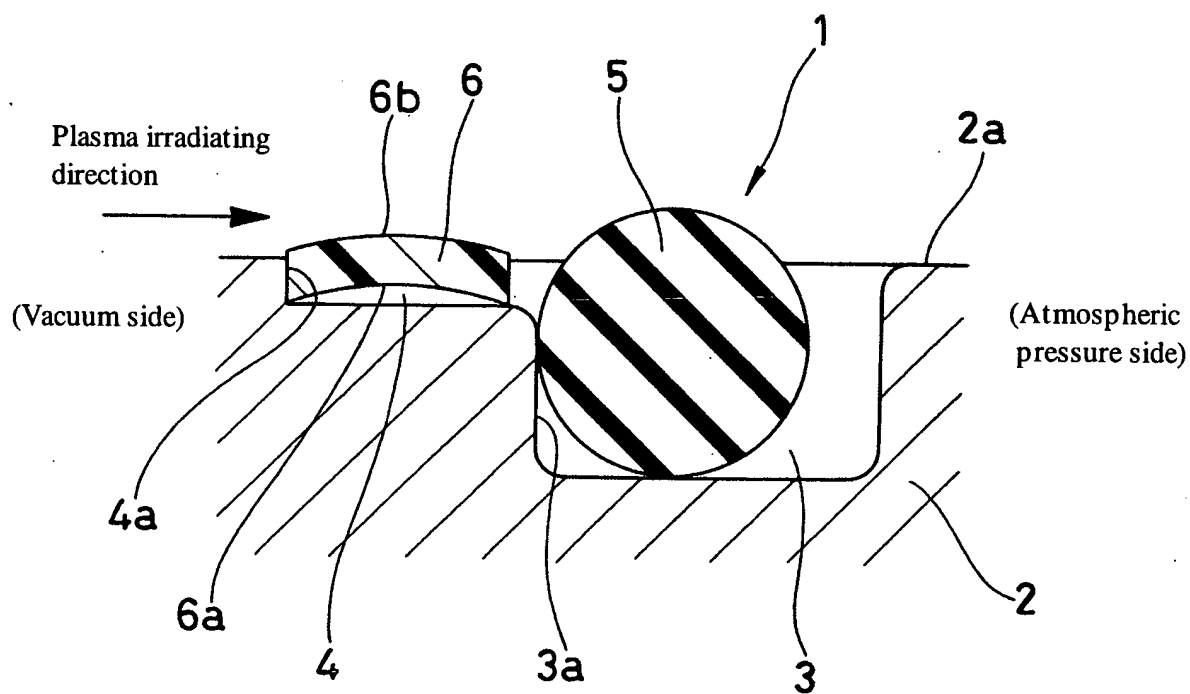


FIG. 3

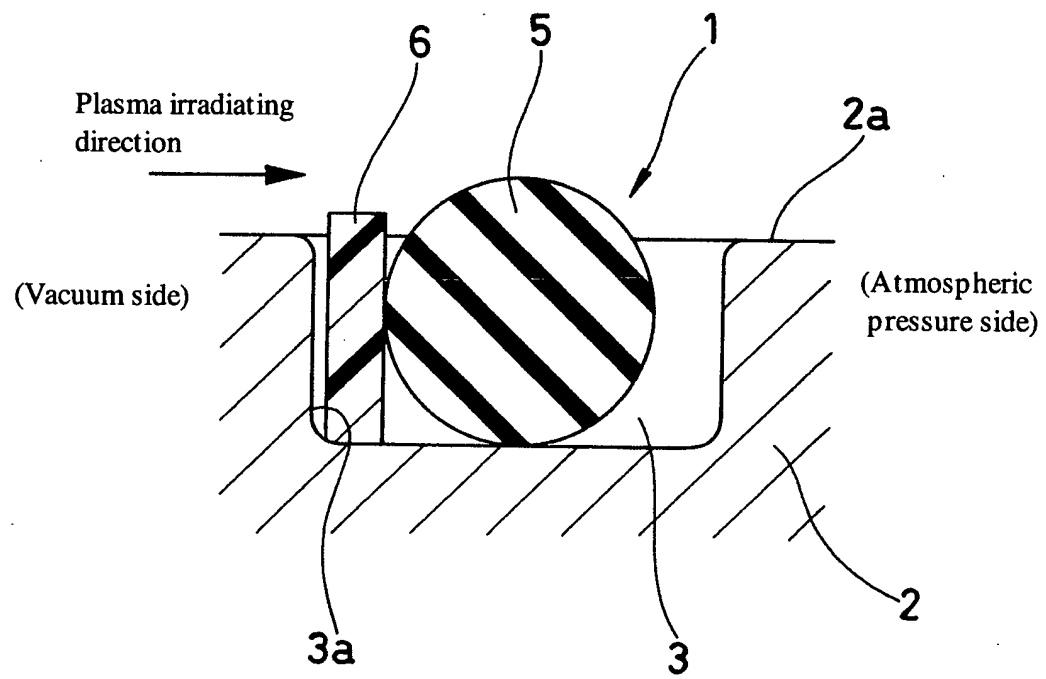


FIG. 4

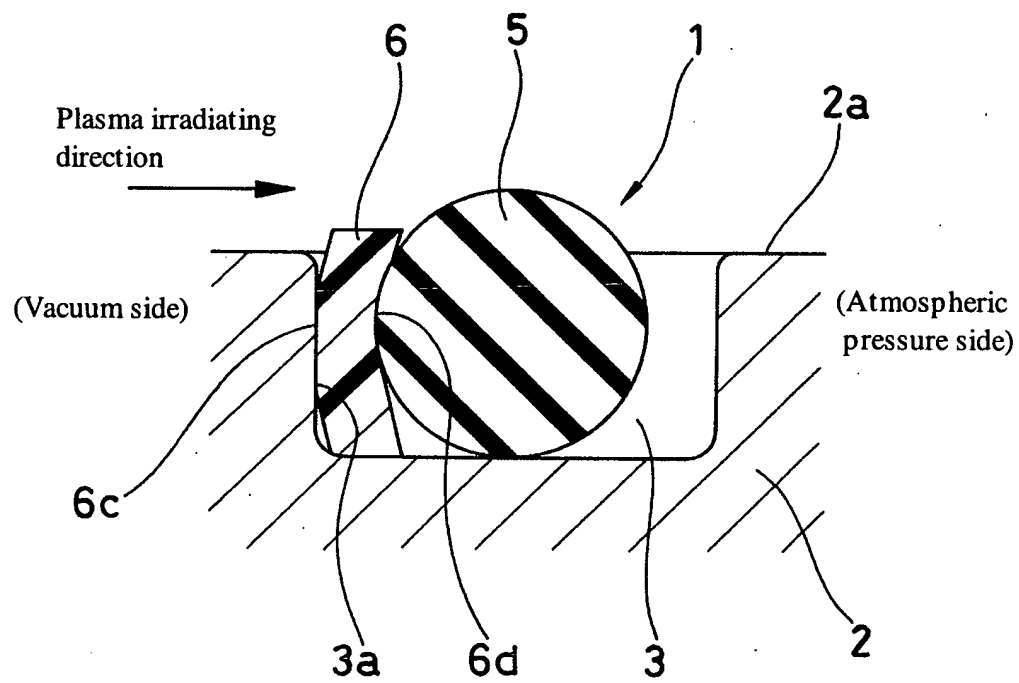


FIG. 5

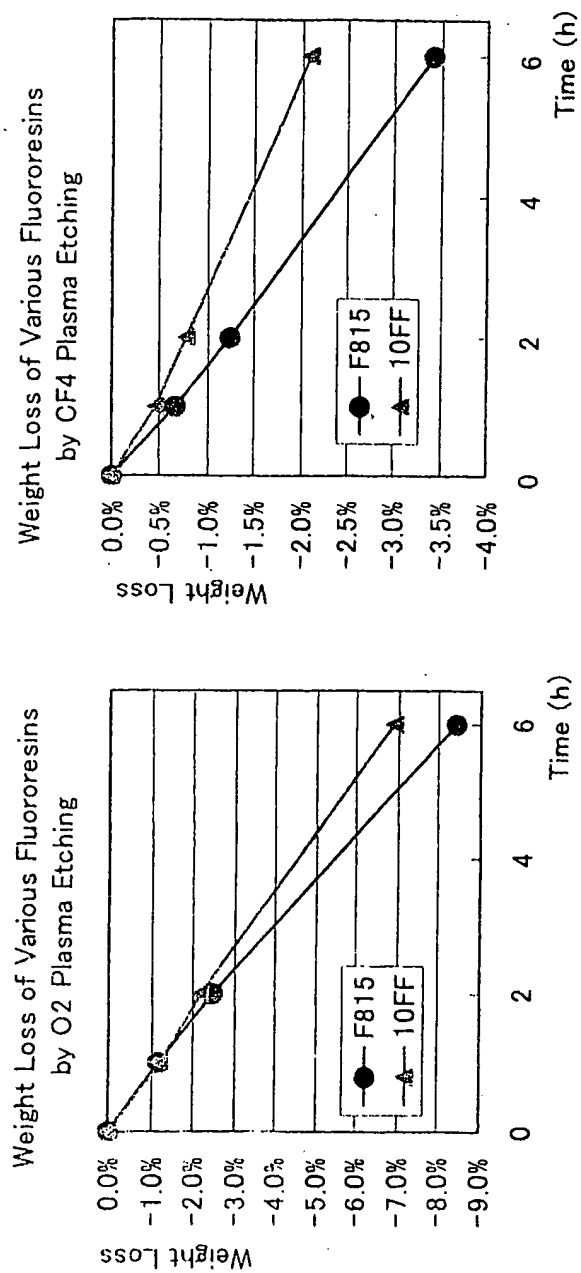


FIG. 6

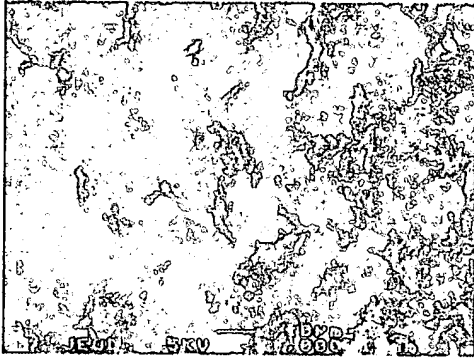

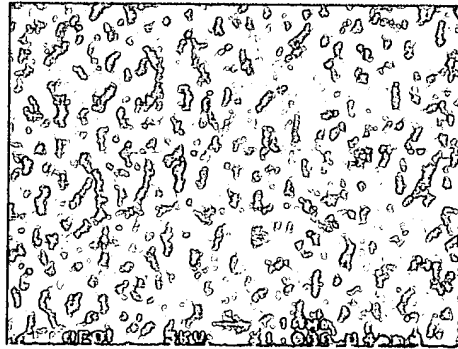
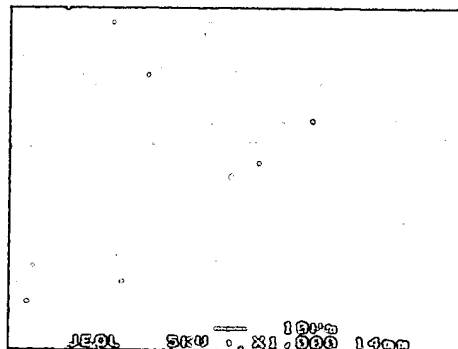
Plasma resistance FKM(O ₂):Direct irradiation	Plasma resistance FKM(O ₂): PTFE Protection
 <p>JEOL 5KV X1,000 14mm</p>	 <p>JEOL 5KV X1,000 14mm</p>
Surface roughness is generated	No surface roughness is generated
Plasma resistance FKM(CF ₄): Direct irradiation	Plasma resistance FKM(CF ₄): PTFE Protection
 <p>JEOL 5KV X1,000 14mm</p>	 <p>JEOL 5KV X1,000 14mm</p>
Surface roughness (etching) is generated	No surface roughness is generated

FIG. 7

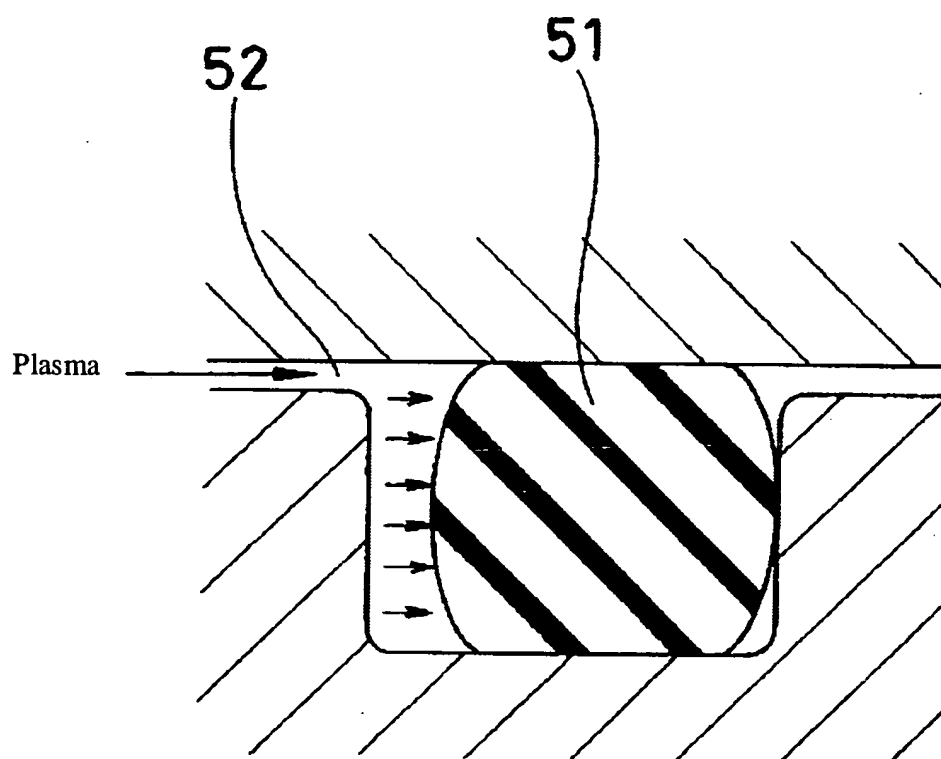


FIG. 8

